INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional) KASA:019	Application Number NEW APPLICATION		
Applicant(s) Tatsutoshi SUZUKI			
Filing Date	Group Art Unit		

				Filing Date December 19, 2	2001	Group Art Unit		
				U.S. PATENT DOCUMENTS		·		
•EXAMINER INTITAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
7	us	5,921,855	7/99	Osterheld et al.	451	527		
2	US	5,984,769	11/99	Bennett et al.	451	527	O E	
/	US	6,241,585	6/01	White	451	41	6504	
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	1		1	FOREIGN PATENT DOCUMENTS	· · ·	<u> </u>	Γ	
, ,	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO	_
1	JP	11-70463	3/99	JAPAN (English Abst.)			✓	
A	JP	47-16044	6/72	JAPAN (Concise Explanation)			1	
X	JP	63-22002	6/88	JAPAN (Concise Explanation)			J	
0	JP	2000-94303	4/00	JAPAN (English Abst.)			/	
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				OTHER DOCUMENTS (Including	g Author, Title,	Date, Pertinent Pa	ges, Etc.)	
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EXAMINE	R	911		DATE CONSIDERED	(L)			
FXAMINE	R: Init	ial if station considered where	or not citation is	in conformance with MPEP Section 609;	9/07 Drawline thro	augh citation if not	in conformance and	_
not conside	red. I	iclude copy of this form with ne	t communication t	o applicant.		common it not	como mance allu	

Form PTO-A820 (also form PTO-1449)

INFORMATION DISCLOSURE TATION

(Use several sheets if necessary)

Docket Number (Optional) KASA:	Application Number 10/026,504			
Applicant(s) Tatsutoshi SUZUKI	•			
Filing Date	Group Art Unit			
December 19, 2001	3723			

U.S. PATENT DOCUMENTS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
OTF	No.							
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Rane	1,5,6					0.00	DE CE	
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				FOREIGN PATENT DOCUMENTS				
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO	
				OTHER DOCUMENTS (Including A	uthor, Title, Da	nte, Pertinent Pag	ges, Etc.)	
1	The Science of CMP; August 20, 1997; pages 113-119; Chapter 4, Part III "Structure and Feature of the polishing pad".							
	_							
EXAMINE	R	SA		DATE CONSIDERED	57			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								

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